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OFFICE OF PETITIONS

In re Application of	:	
Mariappan P. Paranthaman et al	:	
Application No. 10/809,174	:	DECISION ON PETITION
Filed: March 23, 2004	:	TO MAKE SPECIAL UNDER
Attorney Docket No. 1323	:	37 C.F.R. § 1.102(c)
	:	

This is a decision on the petition under 37 CFR 1.102(c), filed on March 23, 2004, to make the above-identified application special based on superconductivity technologies as set forth in M.P.E.P. § 708.02, Section IX.

The petition is **GRANTED**.


A grantable petition to make an application special under 37 CFR 1.102(c) and MPEP § 708.02, Section IX: Special Status for Patent Applications Relating to Superconductivity, must be accompanied by a statement that the invention involves superconductive materials. Examples of such inventions would include those directed to superconductive materials themselves as well as to their manufacture and application. No fee is required.

The instant petition includes a statement under 37 CFR 1.102 that the invention involves superconductive materials. The invention is directed to a structure having an iridium substrate in a biaxially textured buffer system. Accordingly, the above-identified application has been accorded "special" status.

Telephone inquiries concerning this decision should be directed to Thurman K. Page at 571-272-0602.

All other inquiries concerning either the examination or status of the application should be directed to the Technology Center.

The application is being forwarded to the Technology Center Art Unit 1754 for action on the merits commensurate with this decision.


David Bucci
Petitions Examiner
Office of Petitions